

INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	Docket number (Optional)	Application Number
	15689.63.1	10/912,750
	Applicant(s)	
	Mikio Iwamura, et al.	
Filing Date	Group Art Unit	
08/04/2004	2681	

U.S. PATENT APPLICATION PUBLICATIONS

FOREIGN PATENT DOCUMENTS

EXAMINER

ELISEO RAMOS-FELICIANO
PRIMARY EXAMINER

DATE CONSIDERED

8/18/06

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.